

DOCKET NO: 252112US26

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
SHOSUKE ENDOH, ET AL. : EXAMINER: DHINGRA, R.
SERIAL NO: 10/828,437 :
FILED: APRIL 21, 2004 : GROUP ART UNIT: 1716
FOR: PLASMA PROCESSING :
APPARATUS, FOCUS RING, AND
SUSCEPTOR

STATEMENT OF SUBSTANCE OF INTERVIEW UNDER MPEP § 713.04

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

A personal interview was conducted on April 27, 2010. During the personal interview Applicant's representative discussed the machine translation of Nishikawa and presented remarks regarding the control of the gas provided to the buffer (21). The response previously filed in the application and currently under review by the Examiner was also discussed. Applicants respectfully submit that, in combination with the interview summary provided by Examiner Dhingra, the comments above meet the requirements for a statement of substance of interview in accordance with MPEP § 713.04.

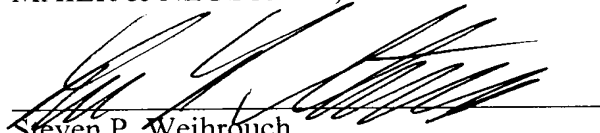
Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
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